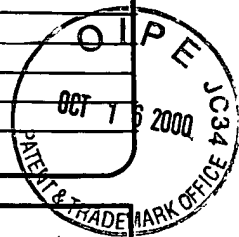


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				Application Number	09/583,386
				Filing Date	May 30, 2000
				First Named Inventor	Carley
				Group Art Unit	2813
				Examiner Name	KIELIN
				Attorney Docket Number	000265
Sheet	1	of	3		

[illegible][illegible]

Examiner Signature	<i>Earl Kitter</i>	Date Considered	<i>5/30/01</i>
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INFORMATION DISCLOSURE STATEMENT BY APPLICANT (use as many sheets as necessary)		Application Number	09/583,386
		Filing Date	May 30, 2000
		First Named Inventor	Carley
		Group Art Unit	2812
		Examiner Name	
Sheet 2 of 3	Attorney Docket Number	000265	

OTHER PRIOR ART - NON PATENT LITERATURE DOCUMENTS		
Examiner Initials*	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.
EK		G.K. FEDDER, S. SANTHANAM, M.L. REED, S.C. EAGLE, D.F. GUILLOU, M.S.-C LU, and L. RICHARD CARLEY, Laminated High-Aspect-Ratio Microstructures in a Conventional CMOS Process, 9th IEEE International Workshop on Micro Electro Mechanical Systems, San Diego, CA USA, Feb. 11-15, 1996.
EK		G.K. FEDDER, S. SANTHANAM, M.L. REED, S.C. EAGLE, D.F. GUILLOU, M.S. C. LU AND L. RICHARD CARLEY, Laminated High-Aspect-Ratio Microstructures in a Conventional CMOS Process, Sensors & Actuators A, vol. 57, No. 2, March 1997, pp. 103-110.
EK		G.K. FEDDER, Integrated Microelectromechanical Systems in Conventional CMOS, 1997 IEEE Int. Symposium on Circuits and Systems, Hong Kong, June 9-12, 1997, v. 4, pp. 2821-2824
EK		G.K. FEDDER, CMOS-Based Microstructures with Lateral Electrostatic Actuation, 1996 Sensors Expo Philadelphia Conf., Philadelphia, PA October 22-24, 1996, pp. 131-135
EK		D.A. KOESTER, R. MAHADEVAN, B. HARDY and K. MARKUS, MUMPS Design Handbook, Cronos Integrated Microsystems, N.C., rev. 3, Oct. 1994.
		Sandia National Laboratories, Intelligent Micro Machine Initiative.
EK		J.H. SMITH, S. MONTAGUE, J.J. SNIEGOWSKI, J.R. MURRAY and P.J. McQHORTER, Embedded Micromechanical Devices for the Monolithic Integration of MEMS with CMOS, IEDM, 1995, pp. 609-612.
EK		M. PARAMESWARAN, A.M. ROBINSON, D.L. BLACKBURN, M. GAITAN and J. GEIST, Micromachined Thermal-Radiation Emitter from a Commercial CMOS Process, 1991 IEEE, Vol. 12, No. 2, pp. 57-59

Examiner Signature	<i>Erik K...</i>	Date Considered	5/30/00
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Sheet 3 of 3

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Application Number 09/583,386
Filing Date May 30, 2000
First Named Inventor Carley
Group Art Unit 2812
Examiner Name
Attorney Docket Number 000265



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EK		X.C. JIN, I. LADABAUM, B.T. KHURI-YAKUB, Surface Micromachined Capacitive Ultrasonic Immersion Transducers, IEEE MEMS Conference, Heidelberg Germany, Jan. 1998	
EK		Q.B. ZOU, Z.M. TAN, Z.F. WANG, M.K. LIM, R.M. LIN, S. YI and Z.J. LI, Design and Fabrication of a Novel Integrated Floating Electrode-Electret-Microphone (FEEM), IEEE MEMS Conference, Heidelberg Germany, Jan. 1998	

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